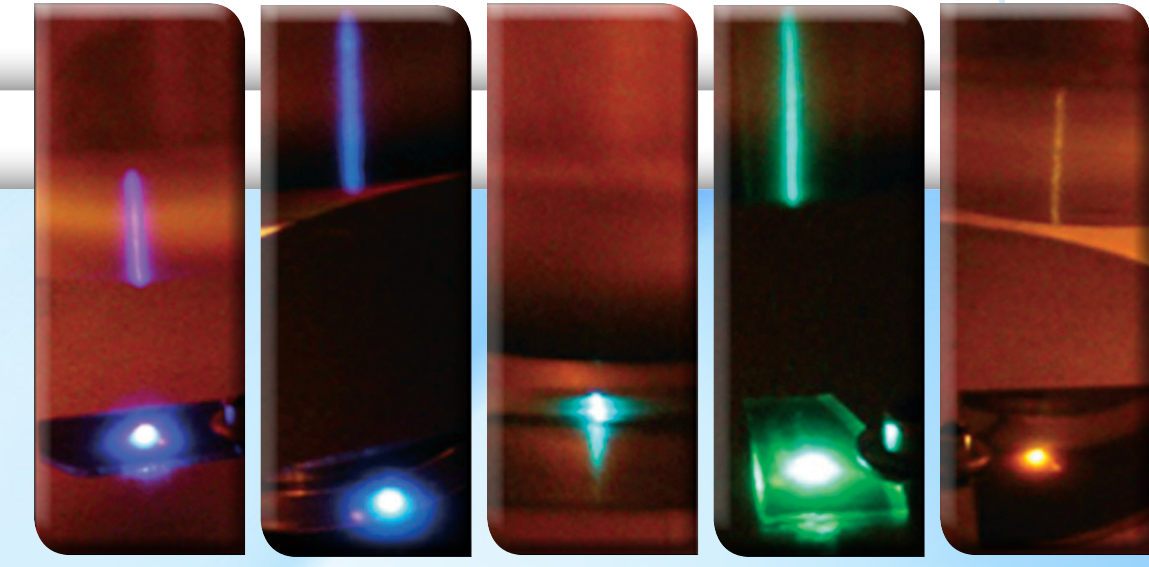


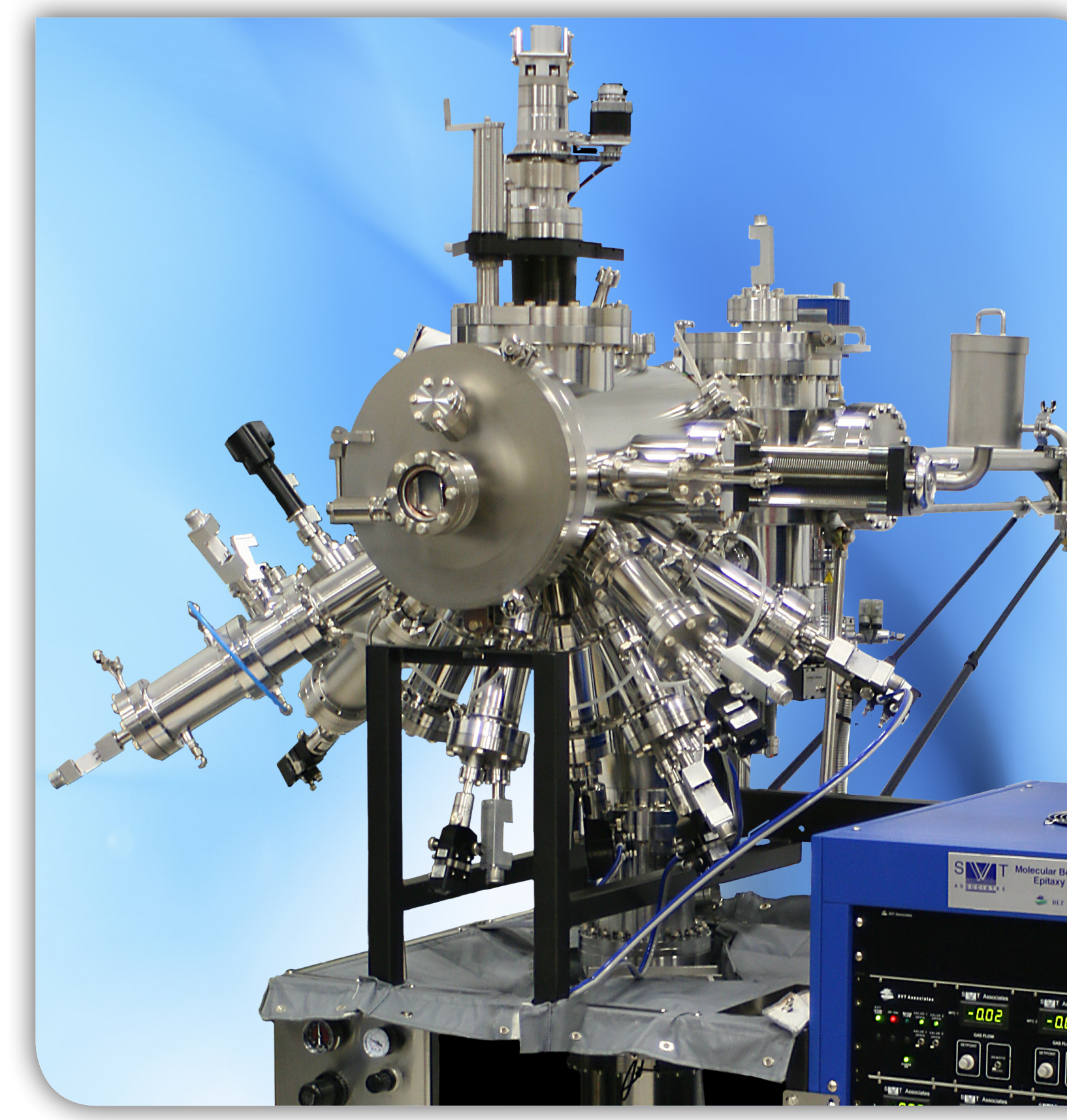
MBE III-V II-VI Oxides Metals



4" MBE System



3" In-Line MBE System



SMART NanoFab MBE System

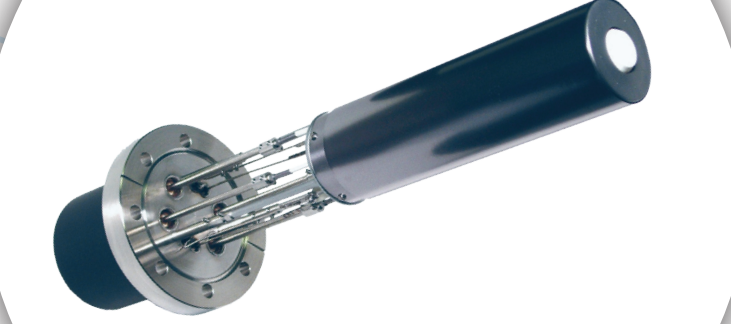


6" MBE System

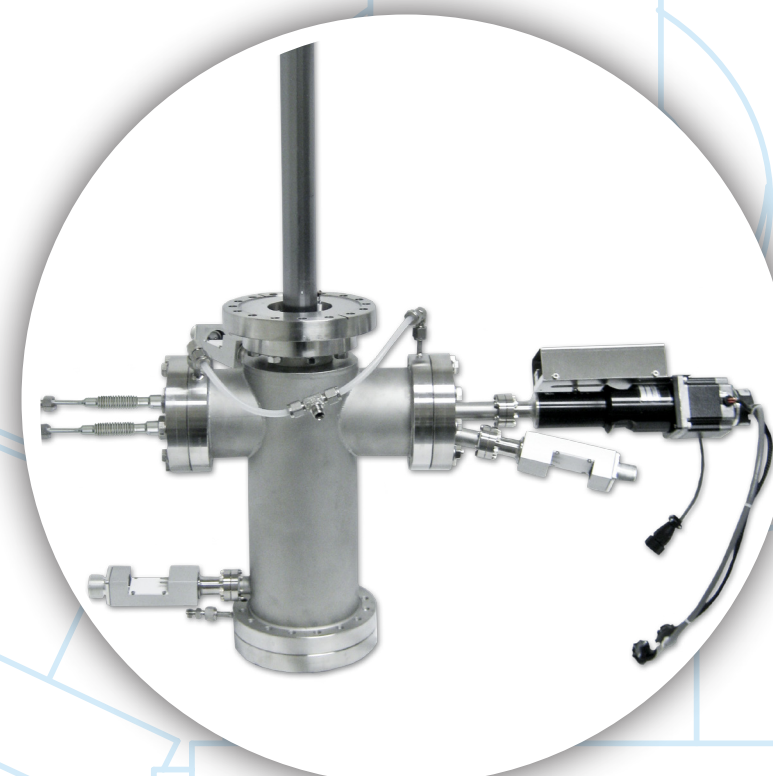


SiGe MBE System

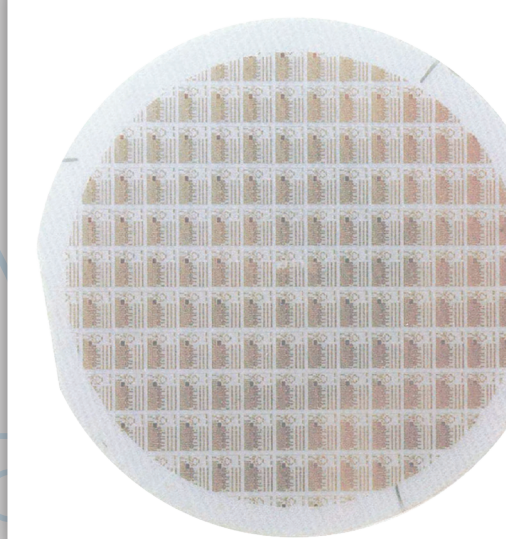
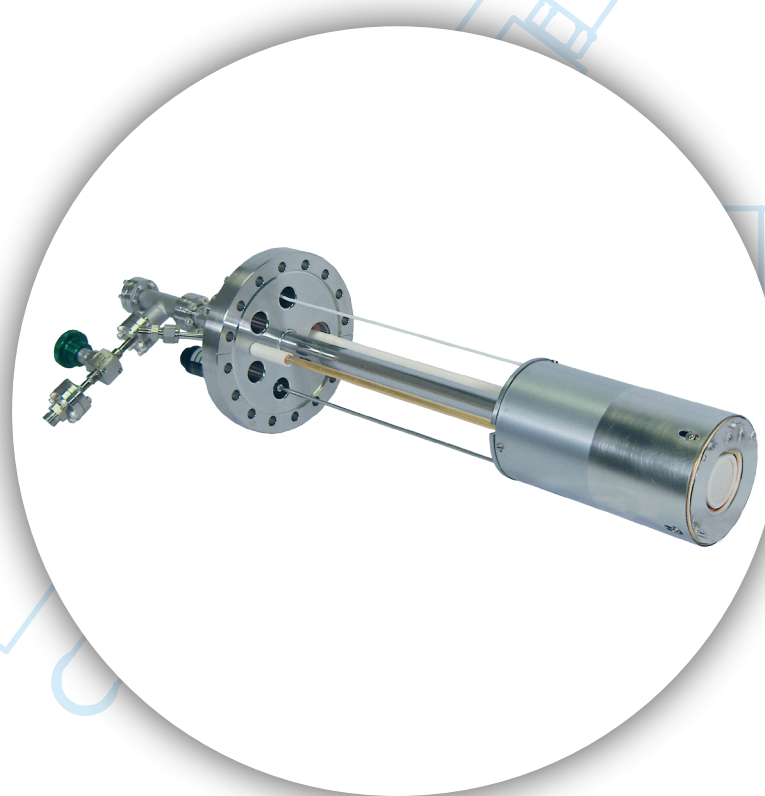
Effusion Cells



Valved Crackers



RF Plasma Sources



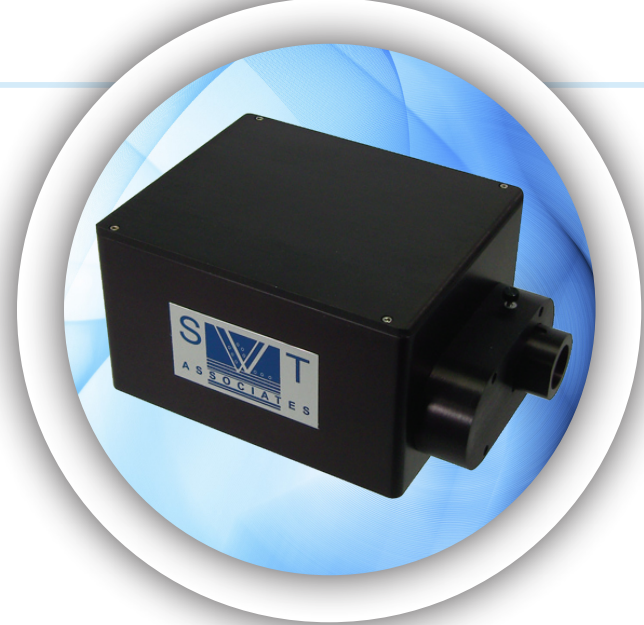
Epi-Wafer Service Available
HEMT, UV Detectors, Superlattices



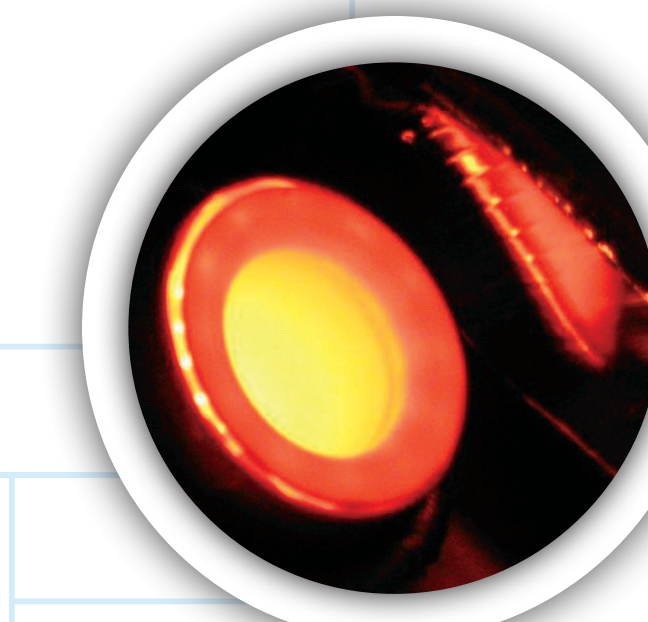
MBE Modules with UHV Cluster Tool



AccuFlux™ Deposition
Flux Monitor



AccuTemp™
In-Situ 4000
Process Monitor



Effusion Cell



Electron Beam
Evaporators